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TRANSMITTAL FORM <i>(to be used for all correspondence after initial filing)</i>	Application Number	09/724,784	
	Filing Date	11/28/2000	
	First Named Inventor	Marc A. Unger	
	Group Art Unit	1772	
	Examiner Name	Unassigned	
Total Number of Pages in This Submission	1	Attorney Docket Number	20174003000

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PATENT
Attorney Docket No.: 20174-003000US
Client Reference No.: 3016-CIP1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Marc Unger et al.

Application No.: 09/724,784

Filed: November 28, 2000

For: MICROFABRICATED
ELASTOMERIC VALVE AND PUMP
SYSTEMS

Examiner: Unassigned

Art Unit: 1772

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.97 and §1.98

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The references cited on attached form PTO/SB/08A/08B are being called to the attention of the Examiner. In accordance with CFR §1.98(d), copies of the references can be found in Application No. 09/605,520, filed June 27, 2000 (Attorney docket No. 20174-000230US), with the exception of reference numbers 1, 24, 28, 52, 59, 63, 67 and 75, copies of which are enclosed herewith. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information, and no inference should be made that the information and references cited are, or are considered to be material to patentability because they are in this statement. No inference should be made that the

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Application Number	09/724,784
Filing Date	11/28/00
First Named Inventor	Marc A. Unger
Group Art Unit	1772
Examiner Name	Unassigned
Attorney Docket Number	20174003000

U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
	1	6,174,365	B1	Sanjoh	01-16-2001	
	2	6,007,309		Hartley	12-28-1999	
	3	5,876,187		Afromowitz et al	03-02-1999	
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	20	WO	99/17093	A1		04-08-1999		
	21	WO	98/07069	A1		02-19-1998		
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	29	GB	2 308 460	A		06-25-1997		
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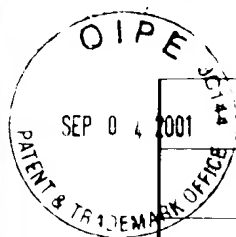
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Application Number	09/724,784
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First Named Inventor	Marc A. Unger
Group Art Unit	1772
Examiner Name	Unassigned
Attorney Docket Number	20174003000

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

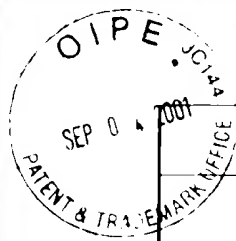
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